



Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 220212US2		SERIAL NO. 10/084,221	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Kazuya OHUCHI			
				FILING DATE February 28, 2002		GROUP 2815	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
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	AH						
	AI						
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	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO						
	AP						
	AQ						
	AR						
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
JN	AW	T-J. KING, et al., IEEE Transactions on Electron Devices, vol. 41, no. 2, pps. 228-232, "ELECTRICAL PROPERTIES OF HEAVILY DOPED POLYCRYSTALLINE SILICON-GERMANIUM FILMS", February 1994					
	AX						
	AY						
	AZ						
Examiner JOSEPH NGUYEN				Date Considered			
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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